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AMENDMENT TRANSMITTAL LETTER				Docket No. 8733.565.00-US	
Application No. 10/025,907 - Conf. #7489	Filing Date December 26, 2001	Examiner Marianne L. Padgett	Art Unit 1762		
Applicant(s): Yun-Ho JUNG					
Invention: APPARATUS AND METHOD OF CRYSTALLIZING AMORPHOUS SILICON					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	14	- 20 =	0	x	0.00
Independent Claims	3	- 3 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					0.00
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0911</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<div style="display: flex; align-items: center; justify-content: center;"><div style="text-align: right; margin-right: 10px;">for <u>Valerie P. Hayes</u></div><div style="text-align: left;"><div style="text-align: right; margin-right: 10px;">Reg. No <u>53,005</u></div><div>Penny L. Caudle Attorney Reg. No.: 46,607</div></div></div>				Dated: <u>August 23, 2005</u>	
MCKENNA LONG & ALDRIDGE LLP 1900 K Street, N.W. Washington, DC 20006 (202) 496-7500					



Docket No.: 8733.565.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Yun-Ho JUNG

Customer No.: 30827

Application No.: 10/025,907

Confirmation No.: 7489

Filed: December 26, 2001

Art Unit: 1762

For: APPARATUS AND METHOD OF
CRYSTALLIZING AMORPHOUS SILICON

Examiner: Marianne L. Padgett

AMENDMENT AFTER FINAL REJECTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated May 23, 2005, Applicant proposes to amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.